

Message Text

CONFIDENTIAL

PAGE 01 STATE 136814

62

ORIGIN EB-11

INFO OCT-01 CIAE-00 COME-00 DODE-00 INR-10 NSAE-00 RSC-01

TRSE-00 EUR-25 AEC-11 ADP-00 /059 R

DRAFTED BY EB/ITP/EWT:LROSS/COMMERCE/OEC:MKRAVETZ:MAR

7/12/73 EXT 22584

APPROVED BY EB/ITP/EWT:RPRACHT

COMMERCE/OEC:JSHEPARD

PE

----- 068885

P R 122142Z JUL 73

FM SECSTATE WASHDC

TO USMISSION OECD PARIS PRIORITY

INFO AMEMBASSY LONDON

AMEMBASSY WARSAW

C O N F I D E N T I A L STATE 136814

EXCON

EO 11652: XGDS-1

TAGS: ESTC, COCOM, US, PL

SUBJ: US SEMICONDUCTOR MANUFACTURING EQUIPMENT TO POLAND

IL 1355

REFS: A. COCOM DOC(73)933

B. STATE 133840

C. OECD PARIS 18811

THE TERM "SILICON CONTROLLED RECTIFIERS" INCLUDES
"THYRISTORS". THE POLES PLAN TO USE FACILITIES IN THIS
CASE FOR THE MANUFACTURE OF 100,000 SILICON CONTROLLED
RECTIFIERS PER YEAR OPERATING AT ONE SHIFT PER DAY. THE
APPLICANT GUARANTEES PRODUCTION QUANTITATIVELY AND
QUALITATIVELY FOR THIS OPERATION. IN ADDITION, HOWEVER,
THE POLES WISH TO USE THESE FACILITIES TO OPERATE A SECOND
SHIFT, BASICALLY ON THEIR OWN, BY WHICH THEY HOPE TO PRODUCE
CONFIDENTIAL

CONFIDENTIAL

PAGE 02 STATE 136814

AN ADDITIONAL 100,000 RECTIFIERS PER YEAR. INASMUCH AS THE

APPLICANT DOES NOT GUARANTEE THE OPERATION OF THE SECOND SHIFT, THE 100,000 RECTIFIERS WHICH THE POLES HOPE TO PRODUCE ON THEIR OWN WERE NOT REFERRED TO IN THE ORIGINAL APPLICATION. FOR REASONS OF EFFICIENCY AND ECONOMY THE FURNACES INVOLVED ARE TO BE OPERATED 24 HOURS PER DAY. OPERATING ON THIS 24-HOUR DAY BASIS, THE SEVEN THREE-TUBE FURNACES (TOTAL OF 21 TUBES) ARE REASONABLE AND NECESSARY FOR THE PRODUCTION OF SUFFICIENT MIX TO PERMIT THE MANUFACTURE OF 200,000 HIGH POWER SEMICONDUCTOR DEVICES PER YEAR.

(NO SILICON DIODE PRODUCTION IS INVOLVED AND DIODES SHOULD NOT HAVE BEEN MENTIONED IN PARA 1 OF ORIGINAL SUBMISSION.)
ROGERS

CONFIDENTIAL

NNN

Message Attributes

Automatic Decaptioning: X
Capture Date: 01 JAN 1994
Channel Indicators: n/a
Current Classification: UNCLASSIFIED
Concepts: n/a
Control Number: n/a
Copy: SINGLE
Draft Date: 12 JUL 1973
Decaption Date: 01 JAN 1960
Decaption Note:
Disposition Action: RELEASED
Disposition Approved on Date:
Disposition Authority: thigpegh
Disposition Case Number: n/a
Disposition Comment: 25 YEAR REVIEW
Disposition Date: 28 MAY 2004
Disposition Event:
Disposition History: n/a
Disposition Reason:
Disposition Remarks:
Document Number: 1973STATE136814
Document Source: CORE
Document Unique ID: 00
Drafter: LROSS/COMMERCE/OEC:MKRAVETZ:MAR
Enclosure: n/a
Executive Order: X1 PRACHT
Errors: N/A
Film Number: n/a
From: STATE
Handling Restrictions: n/a
Image Path:
ISecure: 1
Legacy Key: link1973/newtext/t19730737/aaaabaul.tel
Line Count: 75
Locator: TEXT ON-LINE
Office: ORIGIN EB
Original Classification: CONFIDENTIAL
Original Handling Restrictions: n/a
Original Previous Classification: n/a
Original Previous Handling Restrictions: n/a
Page Count: 2
Previous Channel Indicators:
Previous Classification: CONFIDENTIAL
Previous Handling Restrictions: n/a
Reference: 73 A. COCOM DOC(73)933
Review Action: RELEASED, APPROVED
Review Authority: thigpegh
Review Comment: n/a
Review Content Flags:
Review Date: 22 AUG 2001
Review Event:
Review Exemptions: n/a
Review History: RELEASED <22-Aug-2001 by smithrj>; APPROVED <18-Oct-2001 by thigpegh>
Review Markings:

Declassified/Released
US Department of State
EO Systematic Review
30 JUN 2005

Review Media Identifier:
Review Referrals: n/a
Review Release Date: n/a
Review Release Event: n/a
Review Transfer Date:
Review Withdrawn Fields: n/a
Secure: OPEN
Status: NATIVE
Subject: US SEMICONDUCTOR MANUFACTURING EQUIPMENT TO POLAND IL 1355
TAGS: ESTC, US, PL, COCOM
To: OECD PARIS
Type: TE
Markings: Declassified/Released US Department of State EO Systematic Review 30 JUN 2005